(12) INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(19) World Intellectual Property Organization

International Bureau



(43) International Publication Date 29 January 2004 (29.01.2004)

PCT

(10) International Publication Number WO 2004/010380 A3

(51) International Patent Classification7:

G06T 7/60

(21) International Application Number:

PCT/GB2003/003052

(22) International Filing Date:

14 July 2003 (14.07.2003)

(25) Filing Language:

English

(26) Publication Language:

English

(30) Priority Data:

0216641.1

18 July 2002 (18.07.2002) GB

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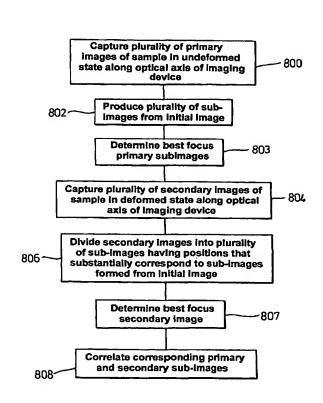
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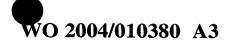
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- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO,

[Continued on next page]

(54) Title: MEASURING 3D DEFORMATIONS OF AN OBJECT BY COMPARING FOCUSING CONDITIONS FOR SHARP CAPTURING OF SAID OBJECT BEFORE AND AFTER DEFORMATION



(57) Abstract: An image analysis apparatus comprises a microscope (102) arranged to capture an image of a sample (122), a processor unit (114) arranged to process the image and a drive mechanism (108). The drive mechanism (108) varies the distance between the sample (122) and the microscope (102) along the optical axis of the microscope (102). The microscope (102) is arranged to capture a plurality of images (402a-404c) of the sample (122) at a plurality of focal planes (distances), along the optical axis. This is done for the sample in a first state and for the sample being in a second state (e.g. before and after deformation of the object). The processor unit (114) is arranged to divide each of the plurality of captured images (402a-404c) into a plurality of sub-images and select one of each of the plurality of sub-images having the best focus characteristics. Both sets of sub-images are compared to determine in-plane and out-of-plane deformations.





SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Published:

- with international search report
- before the expiration of the time limit for amending the claims and to be republished in the event of receipt of amendments
- (88) Date of publication of the international search report: 29 July 2004

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.



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PCT/GB 03/03052

			FCI/GB US/	03032
A. CLASSIFICATION OF SUBJECT MATTER IPC 7 G06T7/60				
According to	International Patent Classification (IPC) or to both national classification	on and IPC		
B. FIELDS S	SEARCHED			
Minimum doo IPC 7	sumentation searched (classification system followed by classification GO6T GO1B GO1C	symbols)		
Documentati	on searched other than minimum documentation to the extent that suc	h documents are incl	uded in the fields sea	arched
	ala base consulted during the International search (name of data base cernal, WPI Data, INSPEC	and, where practical	, search terms used)	
C. DOCUME	NTS CONSIDERED TO BE RELEVANT			
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	MicroDac" 	/		
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	actual completion of the international search		the international sea	rch report
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Name and	malling address of the ISA European Patent Office, P.B. 5818 Patentlaan 2 NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl, Fax: (+31-70) 340-3016	Authorized officer	rock, T	



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		relevant to claim No.
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